Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/627,563	LEWRY ET AL.
Examiner	Art Unit
Shih-Chao Chen	2821

SEARCHED				
Class	Subclass	Date	Examiner	
343	781CA, 781P, 837, 840	4/29/2005	CHEN	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NO (INCLUDING SEARCH)
	DATE	EXMR
EAST (search items: reflector, subreflector, wveguide, feed, hub, dielectric).	4/29/2005	CHEN
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